

Docket No. 205890US99

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jamal RAMDANI et al.

SERIAL NO: 09/721,566

FILED: NOVEMBER 22, 2000

FOR: STRUCTURE AND METHOD FOR FABRICATING SEMICONDUCTOR STRUCTURES AND DEVICES UTILIZING THE FORMATION OF A COMPLETE SUBSTRATE FOR MATERIALS USED TO FORM THE SAME

CONFIRMATION OF ATTORNEY AND
CORRESPONDENCE ADDRESS

ASSISTANT COMMISSIONER FOR PATENTS
WASHINGTON, D.C. 20231

SIR:

The undersigned hereby confirms the attorneys of record for the above-identified application as those appearing in the Revocation and New Appointment of Power of Attorney filed herewith, and accordingly requests the appropriate attorneys of record be noted, and the correct correspondence address be entered for this application as follows:

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Respectfully submitted,

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